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CENTRAL FAX CENTER**

MAR 14 2006

PATENT APPLICATION
Docket No.: 8750-038
Client Ref. No.: SPX200212-0009US**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Sung-Jin KIM, et al.

Serial No.: 10/685,655

Examiner:

Vu, Hung K.

Filed: October 14, 2003

Group Art Unit:

2811

Confirmation No.: 5662

For: PHOTO MASK SET FOR FORMING MULTI-LAYERED
INTERCONNECTION LINES AND SEMICONDUCTOR DEVICE
FABRICATED USING THE SAMEMail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**INFORMATION DISCLOSURE STATEMENT**

Sir:

This Information Disclosure Statement is submitted:

- ☒ under 37 CFR 1.97 (b); or
(Within three months of filing national application; or date of entry of
International application; or before mailing date of first office action on the
merits; or before the mailing of a first Office Action after the filing of a request
for continued examination under §1.114; whichever occurs last)
- ☐ under 37 CFR 1.97 (c) together with either a:
☐ Statement under 37 CFR 1.97 (e), or
☐ a \$180 fee under 37 CFR 1.17 (p); or
(After mailing of first Office Action, but prior to Notice of Allowance or Final

Office Action)

- ☐ under 37 CFR 1.97 (d) together with:
☐ Statement under 37 CFR 1.97 (e), and
☐ a \$180.00 fee set forth in 37 CFR 1.17 (p).

(Filed after final action or notice of allowance, whichever occurs first, but
before payment of the issue fee)

☒ Applicant(s) submit herewith Form PTO 1449- Information Disclosure Citation
together with copies of patents, publications or other information of which applicant(s) are
aware, which applicant(s) believe(s) may be material to the examination of this application and
for which there may be a duty to disclose in accordance with 37 CFR 1.56.

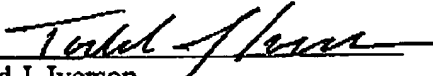
It is requested that the information disclosed herein be made of record in this
application.

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703. A duplicate copy of this sheet is enclosed.

Customer No. 20575


Respectfully submitted,

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I hereby certify that this correspondence
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Li Mei Vermilya

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FABRICATED USING THE SAME**INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)****U.S. PATENT DOCUMENTS**

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Issue</u> <u>Date</u>	<u>Name</u>	<u>Class</u>	<u>Sub</u> <u>Class</u>
_____	_____	5,922,495	Jul. 13, 99	Kim		

FOREIGN PATENT DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Publication</u> <u>Date</u>	<u>Country</u>	<u>Name</u>
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OTHER DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, Etc.)</u>
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Examiner: _____

Date Considered: _____